



Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No. 30320/15128	Serial No. 10/652,323
<b>INFORMATION DISCLOSURE STATEMENT</b>		Applicant	
		Elqag et al.	
		Filing Date August 29, 2003	Group 17C

U.S. PATENT DOCUMENTS							
*Examiner Initials		Document Number	Issue Date	Name	Class	Subclass	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS								
*Examiner Initials		Document Number	Publication Date	Country	Class	Subclass	Translation	
							Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
<i>W</i>		"Amorphous Silicon Waveguides and Light Modulators for Integrated Photonics Realized by Low Temperature Plasma Enhanced Chemical Vapor Deposition," <i>Opt. Lett.</i> vol. 21, no. 24, p. 2002-2004 (1996).
<i>W</i>		B. Jalali et al., "Advances in Silicon-on-Insulator Optoelectronics" <i>IEEE J. Sel. Top. Quantum Elec.</i> , vol. 4, no. 6, p. 938-947 (Nov./Dec. 1998).

Examiner <i>W</i>	Date Considered <i>1/25/06</i>
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	